

In re application of

Docket No: Q77321

Hiroshi OKUMURA

Appln. No.: 10/773,333

Group Art Unit: 2826

Confirmation No.: 8920

Examiner: Johannes P. MONDT

Filed: February 09, 2004

For: THIN FILM TRANSISTOR SUBSTRATE AND METHOD FOR MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.97 and 1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

- 1. Japanese Laid-Open Patent Application Publication No. 2003-045892, published February 14, 2003, previously submitted in an Information Disclosure Statement dated February 9, 2004.
- 2. Japanese Laid-Open Patent Application Publication No. 2000-058849, published February 25, 2000.
- 3. Japanese Unexamined Patent Application Publication No. H11-307777, published November 5, 1999, previously submitted in an Information Disclosure Statement dated February 9, 2004.
- 4. Japanese Laid-Open Patent Application Publication No. 2003-017502, published January 17, 2003.

One copy of each of the listed documents is submitted herewith.

The present Information Disclosure Statement is being filed after the later of three months from the application's filing date and the mailing date of the first Office Action on the

INFORMATION DISCLOSURE STATEMENT

U.S. Appln. No.: 10/773,333

Atty. Docket No.: Q77321

merits, but before a Final Office Action, Notice of Allowance, or an action that otherwise closes

prosecution in the application (whichever is earlier), and therefore Applicant is filing

concurrently herewith a Statement Under 37 C.F.R. § 1.97(e). No fee under 37 C.F.R. § 1.17(p)

is required.

In compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3) for

foreign language documents, Applicant encloses here with a copy of a corresponding Japanese

Office Action dated May 6, 2005, and an English translation of the pertinent portions thereof

which cites such documents and indicates the degree for relevance found by the foreign office.

The submission of the listed documents is not intended as an admission that any such

document constitutes prior art against the claims of the present application. Applicant does not

waive any right to take any action that would be appropriate to antedate or otherwise remove any

listed document as a competent reference against the claims of the present application.

The USPTO is directed and authorized to charge all required fees, except for the Issue

Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any

overpayments to said Deposit Account. A duplicate copy of this paper is attached.

Respectfully submitted,

Registration No. 25.665

SUGHRUE MION, PLLC

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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: June 9, 2005

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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q77321

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Examiner: Johannes P MONDT

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For:

THIN FILM TRANSISTOR SUBSTRATE AND METHOD FOR MANUFACTURING

THE SAME

STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,

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WASHINGTON OFFICE CUSTOMER NUMBER

Date: June 9, 2005

Registration No. 25,665

Substitute for Form 1449 A & B/PTO

INFORMATION DISCLOSURE STATEMENT BY APREICANT

(use as many sheets as necessary)

Sheet	1	of	1_	

Сотр	olete if Known
Application Number	10/773,333
Confirmation Number	8920
Filing Date	February 09, 2004
First Named Inventor	Hiroshi OKUMURA
Art Unit	2826
Examiner Name	Johannes P MONDT
Attorney Docket Number	Q77321

U.S. PATENT DOCUMENTS						
Examiner Cite Initials* No.1	Cita	Document Number		Publication Date		
		Number	Kind Code ² (if known)	MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	
		US				
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Examiner Cite Initials* No.1	Foreign Patent Document			Publication Date	Name of Patentee or		
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation ⁶
		JP	2003-045892	A	02-14-2003		
		JP	2000-058849	A	02-25-2000		
		JP	H11-307777	A	11-05-1999		
		JP	2003-017502	A	01-17-2003		
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	NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*					
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Examiner Signature	Date Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.